

<b>PTO-1449</b>  <b>Information Disclosure Citation In an Application</b>			Application No. <b>10/052,886</b>		Applicant(s) <b>Seemant (nmi) Choudhary et al.</b>		
			Docket Number <b>064731.0263</b>		Group Art Unit <b>2633</b>		Filing Date <b>January 18, 2002</b>
<b>U.S. PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
	A						
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<b>FOREIGN PATENT DOCUMENTS</b>							
		<b>DOCUMENT NO.</b>	<b>DATE</b>	<b>COUNTRY</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>TRANSLATION</b>
							<b>YES</b> <b>NO</b>
	C	GB 2 370 473	06/26/2002	United Kingdom			
	D	JP 3-251827	11/11/1991	JAPAN			
	E	JP 8-181391	12/07/1996	JAPAN			
	F						
<b>NON-PATENT DOCUMENTS</b>							
		<b>DOCUMENT (Including Author, Title, Source, and Pertinent Pages)</b>					<b>DATE</b>
	G	Office Action for Application No. 2003-009997, received 12/16/2008, 1 page					12/16/2008
	H	Tetsuya et al., "Optical Phase Detection System," Patent Abstracts of Japan, Publication No. 04-249434, 2 pages, September 4, 1992					09/04/1992
	I	Takashi et al., "Surface Emitting Laser, Surface Emitting Laser Array, and Optical Information Processing Equipment," Patent Abstracts of Japan, Publication No. 08-181391, 1 page, December 7, 1996					12/07/1996
	J						
	K						
	L						
	M						
	N						
	O						
	P						
	Q						
EXAMINER /Agustin Bello/ (01/31/2009)						DATE CONSIDERED	
<small>EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.</small>							

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /A.B./